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**FACSIMILE TRANSMISSION COVER SHEET**

Date: April 29, 2005

To: United States Patent and Trademark Office  
Examiner: Luu, Chuong A; Art Unit: 2818

Fax: (703) 872-9306

Re: **Application Serial No.: 09/575,055**  
Filing Date: 5/19/2000; First-Named Inventor: Liu  
Attorney Docket No.: 99CON114P

From: Farjami & Farjami LLP

Number of pages including the cover sheet: 13

Message:

Enclosed please find the Amendment and Response to Non-Final Office Action dated January 31, 2005.

Thank you.

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Attorney Docket No.: 99CON114P

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of: Liu, et al.

Art Unit: 2818

APR 29 2005

Serial No.: 09/575,055

Examiner: Luu, Chuong A.

Filed: May 19, 2000

For: Method for Selective Fabrication of  
High Capacitance Density Areas in a  
Low Dielectric Constant Material

AMENDMENT AND RESPONSE TO NON-FINAL OFFICE ACTION

Honorable Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir/Madam:

This is in response to the Non-Final Office Action dated January 31, 2005 in the above-referenced patent application. Please enter and consider the following amendments and remarks.